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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

McQuade, Francis T.

Barto, Charles L.

Docket:

102276-200

Serial No.:

10/027,146

Art Unit:

Filed:

Examiner:

1741

Assignee:

December 20, 2001

Wenthworth Laboratories, Inc.

Conf. No.:

3054

Title:

Method for chemically etching photo-defined micro electrical contacts

Certificate of Mailing

Date of Deposit:

I hereby certify under 37 CFR 1.8(a) that this correspondence (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to Commissioner for Patents, Washington, DC 20231.

Signed:

Name:

INFORMATION DISCLOSURE STATEMENT TRANSMITTAL

Commissioner for Patents Washington, DC 20231

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NOV 2 5 2002

Dear Sir:

OFFICE OF PETITIONS

Applicant wishes to make of record the items on attached Form PTO-1449.

The undersigned represents that the closest art of which he is presently aware has been cited herein and understands that this statement shall not be construed as representation that no better art exists or that a thorough patentability search has been made.

Date:

WIGGIN & DANA One Century Tower New Haven, CT 06508-1832 Phone: (203) 498-4566

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Respectfully submitted,

Gregory S. Rosenblatt Attorney for Applicant

Reg. No.: 32,489